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INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 4590-413		U.S. APPLICATION NO. 6,715,597 B1 Not yet assigned	
				APPLICANT Pierre GALLON et al.			
				FILING DATE herewith		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
HK	5,992,233A	1999-11-30	Clark William A				
HK	5,747,690A	1998-05-05	Lee Chong-Won et al				
HK	6 253 612 B1	2001-07-03	Juneau Thor N et al				
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation Yes No	
HK	98/15799A	1998-04-16	WIPO				
HK	0 642 216 A	1995-03-08	EP				
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
HK	Mochida Y et al: "A micromachined vibrating rate gyroscope with independent beams for the drive and detection modes". Micro Electro Mechanical Systems, 1999 MEMS '99 Twelfth IEEE International Conference On Orlando FL, USA 17 January, 1999, pages 618-623						
EXAMINER /Helen Kwok/				DATE CONSIDERED 05/04/2006			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.